

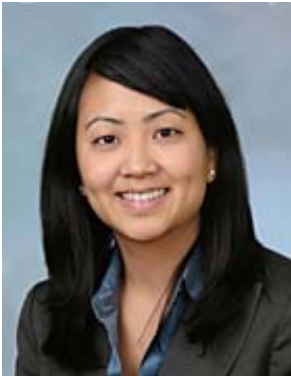


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**JULIA A. KIM**  
**Associate**



Ms. Kim's practice is focused on patent litigation and prosecution. Her technical expertise is in molecular and cellular biology.

Ms. Kim received her J.D. from the University of Arizona, James E. Rogers College of Law in 2007. Ms. Kim gained relevant work experiences while serving as an intern for the Honorable Randall R. Rader, Circuit Judge, at the United States Court of Appeals for the Federal Circuit; Administrative Patent Judges Nancy Linck and Toni Scheiner at the USPTO Board of Patent Appeals and Interferences; and the Honorable Raner C. Collins, U.S. District Court for the District of Arizona.

Ms. Kim is a member of the American Bar Association, Section of Intellectual Property Law and Section of Litigation. Ms. Kim is admitted to practice before the United States Patent and Trademark Office.

**Area of Concentration**

- Litigation
  - Hatch-Waxman
- Patent Prosecution

**Education**

- University of Arizona (B.S., Molecular and Cellular Biology, 2004) (*Magna Cum Laude*, with Honors)
- University of Arizona (J.D., 2007)

**Bar Admissions**

- District of Columbia Bar
- United States Patent and Trademark Office